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APPLICATION NO.]	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.		
10/611,395		06/30/2003	Shriram Ramanathan	42P16666	1525		
8791	7590	01/07/2005	•	EXAMINER			
	BLAKELY SOKOLOFF TAYLOR & ZAFMAN 12400 WILSHIRE BOULEVARD			BEREZNY, NEMA O			
SEVENTH I		OOLLVARD		ART UNIT	PAPER NUMBER		
LOS ANGE	LOS ANGELES, CA 90025-1030			2813			
					DATE MAILED: 01/07/2005		

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)			
		10/611,395	RAMANATHAN ET AL.			
	Office Action Summary	Examiner	Art Unit			
		Nema O. Berezny	2813			
Period fo	The MAILING DATE of this communication apor Reply	opears on the cover sheet w	ith the correspondence address			
THE - External formal f	ORTENED STATUTORY PERIOD FOR REP MAILING DATE OF THIS COMMUNICATION nsions of time may be available under the provisions of 37 CFR 1 SIX (6) MONTHS from the mailing date of this communication. e period for reply specified above is less than thirty (30) days, a re period for reply is specified above, the maximum statutory period are to reply within the set or extended period for reply will, by status reply received by the Office later than three months after the mailing ed patent term adjustment. See 37 CFR 1.704(b).	136(a). In no event, however, may a ply within the statutory minimum of third will apply and will expire SIX (6) MON te. cause the application to become A	reply be timely filed ty (30) days will be considered timely. NTHS from the mailing date of this communication. BANDONED (35 U.S.C. § 133).			
Status						
1)⊠	Responsive to communication(s) filed on 21	October 2004.				
· · · · · ·		is action is non-final.				
3)						
	closed in accordance with the practice under	Ex parte Quayle, 1935 C.D). 11, 453 O.G. 213.			
Dispositi	ion of Claims					
5)□ 6)⊠ 7)⊠	Claim(s) <u>1-42</u> is/are pending in the application 4a) Of the above claim(s) <u>28-42</u> is/are withdray Claim(s) is/are allowed. Claim(s) <u>1-11 and 13-26</u> is/are rejected. Claim(s) <u>12 and 27</u> is/are objected to. Claim(s) are subject to restriction and/	wn from consideration.				
Applicati	on Papers					
9) 🗌 🤈	The specification is objected to by the Examin	er.				
10)🛛	The drawing(s) filed on <u>30 June 2003</u> is/are:	a)⊠ accepted or b)⊡ obje	cted to by the Examiner.			
	Applicant may not request that any objection to the	e drawing(s) be held in abeyar	nce. See 37 CFR 1.85(a).			
11)	Replacement drawing sheet(s) including the correct The oath or declaration is objected to by the E	•	• • • • • • • • • • • • • • • • • • • •			
Priority u	ınder 35 U.S.C. § 119					
	Acknowledgment is made of a claim for foreig All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority document application from the International Burea	nts have been received. Its have been received in A pority documents have been	opplication No			
* S	See the attached detailed Office action for a lis	t of the certified copies not	received.			
Attachment	t(s)		,			
1) 🔲 Notic	e of References Cited (PTO-892)	4) Interview S	Summary (PTO-413)			
3) 🔲 Inform	e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449 or PTO/SB/08 r No(s)/Mail Date		s)/Mail Date nformal Patent Application (PTO-152)			

This Office Action is in response to Applicant's Amendment, filed 10-21-04 which has been entered and considered. Claims 1-42 are currently pending, with claims 28-42 withdrawn.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1-2, 5, 7, 13-14, 20, and 22 are rejected under 35 U.S.C. 102(b) as being anticipated by Kim (6,380,629). Kim discloses a method comprising: depositing a layer of a metal (Fig.3-4,9,13 el.31) on each of a number of conductors (el.11) disposed on a surface of a first wafer (el.10); and forming a bond (el.33) between the metal layer on one of the conductors of the first wafer and one of a number of corresponding conductors (el.21) on a surface of a second wafer (el.20) [claim 1].

Based upon the rejection of claim 1 above, Kim also discloses prior to depositing the metal layer on each of the conductors, removing dielectric material from the surface of the first wafer (col.4 lines 7-10) [claim 2]; wherein the metal comprises one of silver, gold, ruthenium, osmium, iridium, palladium, rhodium, and platinum (col.5 lines 58-60) [claim 5]; and wherein depositing the layer of metal on each of the conductors

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comprises: forming a blanket layer of the metal over the conductors and the surface of the wafer; and removing the metal from the wafer surfaces (col.4 lines 11-15) [claim 7].

Kim also discloses a method comprising: depositing a layer of a first metal (Fig.3-4,9,13 el.31) on each of a number of conductors (el.11) disposed on a first wafer (el.10); depositing a layer of a second metal (el.32) on each of a number of conductors (el.21) disposed on a second wafer (el.20); aligning the first wafer with the second wafer; and forming a bond (el.33) between the metal layer on one of the conductors of the first wafer and the metal layer on a mating one of the conductors of the second wafer, wherein the bonded metal layers are disposed between the mating conductors (col.4 lines 1-15, 39-41) [claim 13].

Based upon the rejection of claim 13 above, Kim also discloses prior to depositing the metal layer on each of the conductors of at least one of the first and second wafers, removing dielectric material from a surface of the at least one wafer (col.4 lines 7-10) [claim 14]; wherein the first metal and the second metal are the same (col.5 lines 58-60) [claim 18]; wherein each of the first and second metals comprises one of silver, gold, ruthenium, osmium, iridium, palladium, rhodium, and platinum (col.5 lines 58-60) [claim 20]; and wherein depositing the metal layer on each of the conductors of at least one of the first and second wafers comprises: forming a blanket metal layer over the conductors and a surface of the wafer; and removing the blanket metal layer from the wafer surface (col.4 lines 11-15) [claim 22].

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Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 3-4, 6, 15, and 21 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kim as applied to claims 1 and 13 above, and further in view of Shih et al. (6,329,722). Kim does not disclose removing native oxide from the conductors, conductors comprising copper, or bonding at a temperature of 100-300 degrees C. However, Kim would look to one such as Shih for lower resistance, a stronger solderable surface, and lower oxidation of metallic surfaces, respectively.

Shih discloses prior to depositing the metal layer on each of the conductors of at least one of the first and second wafers, removing native oxide from the conductors (col.3 lines 1-6). Therefore, it would have been obvious to a person of ordinary skill in the art at the time of the invention to use the native oxide removal of Shih with the method of Kim in order to provide lower resistance and therefore a better mechanical bond (an inherent property of native oxide increases resistance) [claims 3, 15].

Shih also discloses wherein the conductors comprise copper (col.2 line 65 - col.3 line 1). Therefore, it would have been obvious to a person of ordinary skill in the art at the time of the invention to use the copper conductors of Shih with the method of Kim in order to provide a strong solderable surface (Shih - col.2 lines 28-31) [claim 4].

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Shih also discloses wherein the bond is formed at a temperature between approximately 100 and 300 degrees Celsius (col.5 lines 49-53). Therefore, it would have been obvious to a person of ordinary skill in the art at the time of the invention to use the bonding temperature of Shih with the method of Kim in order to provide less oxidation of the metallic surfaces at a lower temperature (Shih - col.5 lines 59-63) [claims 6, 21].

Claims 8-11, 16-17, and 23-26 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kim as applied to claims 1 and 13 above, and further in view of Neuhaus et al. (200210027294). Kim does not disclose selectively depositing a metal on the conductors comprising a number of islands, or the conductors of the first and second wafers comprising the same metal or comprising copper. However, Kim would look to one such as Neuhaus for reduction of fabrication steps, a better electrical and mechanical bond, and conductors with higher conductivity. Neuhaus discloses wherein depositing the layer of metal on each of the conductors of at least one of the first and second wafers comprises selectively depositing the metal on each of the conductors using one of an electroless plating process, an electroplating process, and a contact displacement plating process (p.4 para.38). Therefore, it would have been obvious to a person of ordinary skill in the art at the time of the invention to use the depositing of Neuhaus with the method of Kim in order to eliminate the fabrication steps of patterning, etching, and removing of material which is required for conventional deposition and patterning of conductors [claims 8, 9, 23, 24].

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Neuhaus discloses wherein the metal layer on each of the conductors of at least one of the first and second wafers comprises a number of islands which are selectively deposited on each of the conductors (p.4 para.50; p.6 para.64). Therefore, it would have been obvious to a person of ordinary skill in the art at the time of the invention to use the metal layer island deposition of Neuhaus with the method of Kim in order to pierce the conductors and form a stronger bond (Neuhaus - p.5 para.57) [claims 10, 11, 25, 26].

Neuhaus discloses wherein the conductors of each of the first and second wafers comprise the same metal (p.4 para.51). Therefore, it would have been obvious to a person of ordinary skill in the art at the time of the invention to use the same metal for conductors of the first and second wafers of Neuhaus with the method of Kim in order to perform the same fabrication step of conductor deposition for both wafers [claim 16].

Neuhaus discloses wherein the conductors of each of the first and second wafers comprise copper (p.3 para.28). Therefore, it would have been obvious to a person of ordinary skill in the art at the time of the invention to use copper metal for conductors of the first and second wafers of Neuhaus with the method of Kim in order to provide conductors of high conductivity (inherent property of copper) [claim 17].

Claim 19 is rejected under 35 U.S.C. 103(a) as being unpatentable over Kim as applied to claim 13 above, and further in view of DiStefano (6,324,754). Kim does not disclose the first and second metals being different. However, Kim would look to one

such as DiStefano for centering solder balls because DiStefano discloses wherein the first metal and the second metal are different (col.6 lines 51-64; co1.10 lines 66-67). Therefore, it would have been obvious to a person of ordinary skill in the art at the time of the invention to use different metals for the first and second metals of Neuhaus with the method of Kim in order to provide centering of the solder balls upon the first and second metals (co1.10 lines 66-67).

Allowable Subject Matter

The following is a statement of reasons for the indication of allowable subject matter, regarding claims 12 and 27: the prior art of record does not teach or disclose or make obvious depositing a blanket layer of metal over conductors and the surface of the wafers, and removing said metal layer from the wafer surface and from portions of each conductor to form a number of islands on each conductor. Neuhaus discloses forming conductive particles or islands to conductors, but not by a subtractive method (p.4 para.38, 50; p.6 para.64).

Claims 12 and 27 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Response to Arguments

Applicant's arguments with respect to claims 1-27 have been considered but are most in view of the new ground(s) of rejection.

Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Nema O. Berezny whose telephone number is (571) 272-1686. The examiner can normally be reached on M-F 9-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead, Jr. can be reached on (571) 272-1702. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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NB

CRAIG A. THOMPSON PRIMARY EXAMINER